



Docket No. 1539.1003RE

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:

Tomowaki Takahashi

Application No.: 09/665,184

Group Art Unit: 2873

Confirmation No.: 4343

Filed: September 15, 2000

Examiner: Evelyn A Lester

For: EXPOSURE APPARATUS HAVING CATADIOPTIC PROJECTION OPTICAL SYSTEM

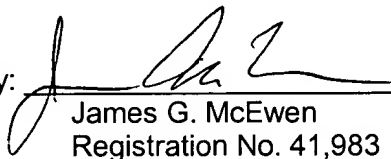
SUBMISSION OF ORIGINAL PATENT PURSUANT TO 37 C.F.R. §1.178

MAIL STOP AF
Commissioner for Patents
PO Box 1450
Alexandria, VA 22313-1450
Sir:

Please find enclosed the original patent for U.S. Patent No. 5,808,805 in compliance with 37 C.F.R. §1.178. As such, it is respectfully submitted that the applicants have complied with the requirements of 37 CFR §1.178.

Respectfully submitted,

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Date: March 29, 2004